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2598/1G196US1

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of: Sang Kyeong YUN and Dong Hoon KIM

Filed: CONCURRENTLY

For: PIEZOELECTRIC/ELECTROSTRICTIVE FILM ELEMENT FORMED AT LOW

TEMPERATURE USING ELECTROPHORETIC DEPOSITION

AMENDMENT MARK-UP SHEET FOR PRELIMINARY AMENDMENT

Hon. Commissioner of Patents and Trademarks Washington, DC 20231

Sir:

In the Claims:

Please amend Claims 22 and 41 to read as follows:

22. (Amended) The piezoelectric/electrostrictive film element in [Claim 20 or] Claim 21, wherein the method further comprises a step of drying said piezoelectric/electrostrictive film between g) and h).

41. (Amended) The piezoelectric/electrostrictive film element in [Claim 39 or] Claim 40, wherein the method further comprises a step of drying the piezoelectric/electrostrictive film between g) and h).

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PATENT TRADEMARK OFFICE

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Docket No.: 2598/1G196US1

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SUBSTITUTE SPECIFICATION

Hon. Commissioner of Patents and Trademarks Washington, DC 20231